

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention

COMPOSITION FOR AN ETCHING MASK COMPRISING A
SILICON-CONTAINING MATERIAL

Application Number : 10/789319
Confirmation Number: 9202
First Named Applicant: Frank Xu
Attorney Docket Number: P121-63-03
Art Unit: 1712
Examiner: Marc S. Zimmer
Search string: (5737064).pn



US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

| init | Cite.No. | Patent No. | Date | Patentee | Kind | Class | Subclass |
|------|----------|------------|------------|--------------|------|-------|----------|
| | 1 | 5737064 | 1998-04-07 | Inoue et al. | | | |

Signature

| Examiner Name | Date |
|---------------|------|
| | |